Attorney's Docket No.:

THE UNITED STATES PATENI ...

: Kusumoto, et al. Art Unit : 2814

: 09/941,367 Examiner : Theresa T. Doan

: August 28, 2001

: METHOD FOR PRODUCING INSULATED GATE THIN FILM

SEMICONDUCTOR DEVICE N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/941,367

Filed

Title

Commissioner for Patents Washington, D.C. 20231

## INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and documents listed on form PTO-1449.

This filing is being made before the receipt of a first Office action on the merits. No fee is required.

Each enclosed document listed on the herewith Form PTO-1449 was cited in a foreign counterpart application not more than three months ago. To the best knowledge of the undersigned, this is the first citation of these items in any communication from a foreign patent office in a counterpart foreign application.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR \$1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Deposit

Sharon Gebhart

Name of Person Signing Certificate



The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Please apply any additional charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 9, 2002

Bing Ai

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